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	Filing Date		2006-04-19
	First Named Inventor		Karg et al.
	Art Unit		
	Examiner Name		
	Attorney Docket Number		CH820030009US1

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1	Nanostructuring with laser radiation in the nearfield of a tip from a scanning force microscope, YAU ET AL., Applied Physic Letters, Vol. 164, no. 1 29032, 1996-12-31	<input type="checkbox"/>
2	Selective area oxidation of silicon with a scanning force microscope, H.C. Day, et al, Applied Physic Letters, Vol. 62, 2691-2693, 1993-5-24	<input type="checkbox"/>

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